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Electronic Patent Application Submission  
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EFS ID: 18922  
Application ID: 10065277  
Title of Invention: High-Power Pulsed Magnetron  
Sputtering  
First Named Inventor: Roman Chistyakov  
Domestic/Foreign Application: Domestic Application  
Filing Date: 2002-09-30  
Effective Receipt Date: 2002-10-16  
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Filing Type: null  
Confirmation Number: 5690  
Attorney Docket Number: ZON-001  
Digital Certificate Holder: cn=Kurt Rauschenbach, ou=Registered Attorneys, ou=Patent and  
Trademark Office, ou=Department of Commerce, o=U.S.  
Government, c=US  
Certificate Message Digest: t51843ylio0aNtkdYFclHQ==





# TRANSMITTAL FORM

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Submission Type: Information  
Disclosure Statement

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Application Number: 10/065,277  
Attorney Docket Number: ZON-001

## High-Power Pulsed Magnetron Sputtering

First Named Inventor: Mr. Roman Chistyakov

### SUBMITTED BY

Name: Dr. Kurt Rauschenbach  
Registration Number: 40,137  
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### Attached Files:

us-information-disclosure-statement

zon-001-idsids.xml

Comments:

# Electronic Information Disclosure Statement




## High-Power Pulsed Magnetron Sputtering

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Application:   
10/065277

Confirmation: 5690

Applicant(s): Roman Chistyakov

Docket Number: ZON-001







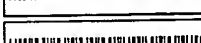
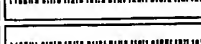
Group Art Unit: 1753

Examiner: Unassigned

search string: ( 5015493 or 6296742 or 6413382 or 6436251 or 5875207 or 4953174 or 6296742 or 4965248 ).pn.

### US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	5015493	1991-05-14		Gruen	427	38
	P02	6296742	2001-10-02		Kouznetsov	204	192.12
	P03	6413382	2002-07-02		Wang et al.	204	192.12
	P04	6436251	2002-08-20		Gopalraja et al.	204	298.12
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	P06	4953174	1990-08-28		Eldridge et al.	372	87
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	P08	4965248	1990-10-23		Poppe et al.	505	1



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## Signature

Examiner Name	Date